

Response Under 37 CFR 1.116

Expedited Procedure

Examining Group 1754

Application No. 09/914,994

Paper Dated: August 20, 2004

In Reply to USPTO Correspondence of May 20, 2004

Attorney Docket No. 388-011500



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/914,994

Applicants : Mitsuaki Echigo et al.

Filed : September 5, 2001

Title : SYSTEM AND METHOD FOR REMOVING
CARBON MONOXIDE

Group Art Unit : 1754 Confirmation No. : 7881

Examiner : Ngoc-Yen M. Nguyen Customer No. : 28289

MAIL STOP AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AFTER FINAL REJECTION

Sir:

In response to the Final Office Action of May 20, 2004, Applicants submit the accompanying Declaration Under 37 C.F.R. §1.132 and the following remarks:

Remarks begin on page 2 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to MAIL STOP AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 20, 2004.

Florence P. Trevethan

(Name of Person Mailing Paper)

Florence P. Trevethan 08/20/2004
Signature Date